

Group Art Unit: 2886
Confirmation No.: 3799
Examiner: Nur, A.

Atty. Ref.: F04-018US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Tohru Koike et al.
Appl. No. : 10/575,714
Filed : May 8, 2006
For : METHOD FOR MEASURING A SURFACE PLASMON RESONANCE AND NOBLE METAL COMPOUND USED FOR THE SAME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(d)

Sir:

The above-identified US patent application was allowed on May 13, 2010. This US application is related to Japanese Patent Appl. No. 2006-058217. An Office Action was issued by the Japanese Patent Office on June 8, 2010, a copy of that Office Action is attached along with an English language translation. The Japanese Examiner cited two references as being relevant. Those references have been listed on the attached copy of Form PTO/SB/08A. Copies of the references are attached along with English language abstracts.

It is believed that neither of these references affects the patentability of the claims as amended and allowed in the United States. Nevertheless, the US Examiner is requested to consider these references and to make the references of record. An indication of allowability is believed to be proper and is requested.

This Information Disclosure Statement is submitted with the statement
specify in 37 CFR 1.97(e)(1) and is accompanied by the fees set forth in 37 CFR
1.17(p).

Respectfully submitted,



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